

claims 1, 3, 5 → 8, 10 → 13, 15 → 20

PATENT
Atty. Dkt. No. AMAT/3032.C7/DSML/OW KJW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Cheung, et al.

Serial No.: 10/647,959

Confirmation No.: 5142

Filed: August 26, 2003

For: Plasma Processes for
Depositing Low Dielectric
Constant FilmsMAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2818

Examiner: Thao P. Le

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DO NOT AVAILABILITY
OR T.6

Please enter
the response amendment. Thanks

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8	
I hereby certify that this correspondence and the documents referred to as attached thereto are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9306 to the attention of the named Examiner, on the date below.	
10/4/04	<i>Keweenaw</i>
Date	Signature

RESPONSE TO FINAL OFFICE ACTION DATED AUGUST 6, 2004

In response to the Final Office Action dated August 6, 2004, having a shortened statutory period for response set to expire on November 6, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3032.C7/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The Pending Claims are listed beginning on page 2 of this paper. Remarks begin on page 5 of this paper.

Page 1

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